Q1(a).

() Ri= 2.5×10<sup>3</sup>/cm<sup>3</sup> (at 300k)  $M_n = 3800 \text{ cm}^2/\text{Vs}$   $M_p = 1800 \text{ cm}^2/\text{Vs}$ (i) Prove that  $P_i = 45 \text{ scm}$ . (at 300 k) J= ne lint peup (m) Mor = e(num + plup) For jutinisic remiconductor, n=p=n; = 0.0224 C Prode O CmVs E COULLY AS CUVS = 0.0224 0.0224 = 44.64 2 cm = 45.2 cm # proven

Q1 (b) and (c).

$$\frac{+5}{2} + \frac{1}{\sqrt{2}} + \frac{1}{$$

$$\frac{1}{12} N_{R} = \frac{1}{2} + \int \left(\frac{1}{2}\right)^{2} - \frac{1}{4} M p N_{1}^{2} dn$$

$$= \frac{2}{4} \kappa 6 \cdot 55 \kappa 10^{2} / a cm C i$$

$$\frac{2}{4} \kappa 6 \cdot 55 \kappa 10^{2} / a cm C i$$

$$\frac{2}{4} \kappa 6 \cdot 55 \kappa 10^{2} / a cm C i$$

$$\frac{2}{4} \kappa 6 \cdot 55 \kappa 10^{2} / a cm C i$$

$$= 3 \cdot 49 \cdot 27 \kappa 10^{4} / \sqrt{5}$$

$$= 3 \cdot 49 \cdot 27 \kappa 10^{4} / \sqrt{5}$$

$$\frac{1}{8} N_{R} = \left(\frac{2 \cdot 5 \kappa 10^{13} / cm^{3}}{3 \cdot 49 \cdot 22 \kappa 10^{13} / cm^{3}}\right)^{2} = 1, 8 \cdot 0, 0 \cdot 11, 52 \cdot 0 / cm^{3}$$

$$\frac{1}{8} N_{R} = \frac{100 / a cm}{1 \cdot 6 \kappa 10^{2} C \kappa} 18 \cdot 0 \cdot 0 \cdot 11, 52 \cdot 0 / cm^{3}$$

$$\frac{1}{8} N_{R} = \frac{100 / a cm}{1 \cdot 6 \kappa 10^{2} C \kappa} 18 \cdot 0 \cdot 0 \cdot 11, 52 \cdot 0 / cm^{3}$$

$$\frac{1}{8} N_{R} = \frac{100 / a cm}{1 \cdot 6 \kappa 10^{2} C \kappa} 18 \cdot 0 \cdot 0 \cdot 11, 52 \cdot 0 / cm^{3}$$

$$\frac{1}{8} N_{R} = \frac{3 \cdot 4 \cdot 22 \kappa 10^{13} / cm^{3}}{1 \cdot 6 \kappa 10^{12} C \kappa} \frac{1 \times 8 \cdot 0}{1 \cdot 6 \kappa 0} \frac{1 \times$$

The purpose of showing the long way of deriving the answer in Q1 (b) and (c) is to prove that the results from both the long way as well as when the assumptions are made are very close. If the question states that assumptions can be made, then use the short way to answer. Q2 (a) and (b).

(C)The diodes are Silicon based on the 0.7021 V across them when they are forward biased.

Q3.

